



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masao MURADE

Group Art Unit: 2871

Application No.: 09/810,615

Examiner: M. Ton

Filed: March 19, 2001

Docket No.: 040342.02

For: AN APPARATUS FOR PROVIDING LIGHT SHIELDING IN A LIQUID CRYSTAL  
DISPLAY (AS AMENDED)

RESPONSE TO RESTRICTION REQUIREMENT

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

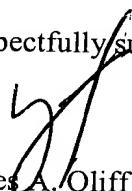
In reply to the March 19, 2003 Restriction Requirement, Applicant provisionally  
elects Group I, claims 34-41, with traverse.

It is also respectfully submitted that the subject matter of all claims is sufficiently  
related that a thorough search for the subject matter of any one Group of claims would  
encompass a search for the subject matter of the remaining claims. Thus, it is respectfully  
submitted that the search and examination of the entire application could be made without  
serious burden. See MPEP §803 in which it is stated that "if the search and examination of  
an entire application can be made without serious burden, the examiner must examine it on  
the merits, even though it includes claims to independent or distinct inventions" (emphasis  
added). It is respectfully submitted that this policy should apply in the present application in  
order to avoid unnecessary delay and expense to Applicants and duplicative examination by  
the Patent Office.

RECEIVED  
APR 15 2003  
TECHNOLOGY CENTER 2800

Thus, withdrawal of the Restriction Requirement is respectfully requested.

Respectfully submitted,

  
James A. Oliff  
Registration No. 27,075

Yong S. Choi  
Registration No. 43,324

JAO:YSC/cfr

Date: April 10, 2003

**OLIFF & BERRIDGE, PLC**  
**P.O. Box 19928**  
**Alexandria, Virginia 22320**  
**Telephone: (703) 836-6400**

<p><b>DEPOSIT ACCOUNT USE AUTHORIZATION</b> Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
---